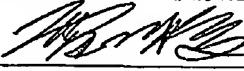


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OCT 19 2005

I hereby certify that the attached PTO form 1449 (3 pages) with 4 cited references (31 pages), Information Disclosure Statement (1 page) are submitted to the U.S. Patent and Trademark Office via facsimile number 571-273-8300 on the date shown below. (Total 35 pages).



Li Mei Vermilya

Date: October 19, 2005

PATENT APPLICATION  
Docket No. 9898-314  
Client No. SS-20035-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.

Serial No.	10/763,356	Examiner:	Pham, Thanhha S.
Filed:	January 23, 2004	Art Unit:	2813
Conformation No.	7097		
For:	ETCHING METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE		

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

under 37 CFR 1.97 (b); or  
 (Within three months of filing national application; or date of entry of International application; or before mailing date of first office action on the merits; or before the mailing of a first Office Action after the filing of a request for continued examination under §1.114; whichever occurs last)

under 37 CFR 1.97 (c) together with either a:  
 Statement under 37 CFR 1.97 (e), or  
 a \$180 fee under 37 CFR 1.17 (p); or  
 (After mailing of first Office Action, but prior to Notice of Allowance or Final Office Action)

under 37 CFR 1.97 (d) together with:  
 Statement under 37 CFR 1.97 (e), and  
 a \$180.00 fee set forth in 37 CFR 1.17 (p).

(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation together with copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

**Customer No. 20575**

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.



Hosoon Lee  
Reg. No. 56,737

MARGER JOHNSON & McCOLLOM, P.C.  
210 SW Morrison Street, Suite 400  
Portland, OR 97204  
503-222-3613

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OCT 19 2005

PATENT APPLICATION  
Docket No. 9898-314  
Client No. SS-20035-US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.

Serial No. 10/763,356 Examiner: Pham, Thanhha S.

Filed: January 23, 2004 Art Unit: 2813

Conformation No. 7097

For: ETCHING METHOD FOR MANUFACTURING  
SEMICONDUCTOR DEVICEMail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT  
(37 CFR 1.97(e))

I, Hosoon Lee, the person signing below state that:  
 each item of information contained in the Information Disclosure Statement submitted  
 herewith was first cited in a communication from a foreign patent office in a counterpart  
 foreign application not more than three months prior to the filing of this Statement

Applicant respectfully requests consideration of the accompanying Information  
 Disclosure Statement.

The person making this Statement is the attorney who signs below on the basis of the  
 information in the attorney's file.

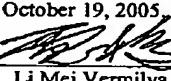
Respectfully submitted,  
 MARGER JOHNSON & McCOLLOM, P.C.



Hosoon Lee  
 Reg. No. 56,737

MARGER JOHNSON & McCOLLOM, P.C.  
 210 SW Morrison Street, Suite 400  
 Portland, OR 97204  
 503-222-3613

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 273-8300, on October 19, 2005.



Li Mei Vermilya

**PATENT APPLICATION**

Atty. Docket No.: 9898-314 Serial No. 10/850,864  
 Applicant: Won-Jun LEE, et al.  
 Filing Date: January 23, 2004 Group: 2812

**INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)****U.S. PATENT DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Issue Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub Class</u>
—	—					

**FOREIGN PATENT DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Document Number</u>	<u>Publication Date</u>	<u>Country</u>	<u>Name</u>
—	—	2002-0083263	Nov. 2, 02	Korea	Hwang, et al.
—	—	2002-0090452	Dec. 5, 02	Korea	Ju, et al.

**OTHER DOCUMENTS**

<u>Exam Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
—	—	English language abstract of Korean Publication No. 2002-0083263
—	—	English language abstract of Korean Publication No. 2002-0090452

Examiner: \_\_\_\_\_

Date Considered: \_\_\_\_\_